



2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method for H2 Recycling In Semiconductor Processing System
Serial No.: 09/828,518 Filing Date: April 6, 2001
Examiner: Olivia T. Luk Group Art Unit: 2812
Docket No.: M-8608 US

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COMMISSIONER FOR PATENTS
Washington, D. C. 20231SUPPLEMENTAL INFORMATION DISCLOSURESTATEMENT UNDER 37 C.F.R. §1.97RECEIVED
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TECHNOLOGY CENTER 2800

Dear Sir:

Pursuant to 37 C.F.R. §1.97, Applicant wishes to call the following documents (copies enclosed) to the attention of the Examiner. The documents were cited in the PCT Search Report for the corresponding PCT Application No. PCT/US02/10487, on October 25, 2002.

1. A PTO form 1449 listing these documents is enclosed.

The relevance of any non-English language documents cited herein is explained in the accompanying copy of the Search Report.

Citation of the above documents shall not be construed as:

1. an admission that the documents are necessarily prior art with respect to the instant invention;

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2. a representation that a search has been made, or
3. an admission that the information cited herein is, or is considered to be material to patentability as defined in §1.56(b).

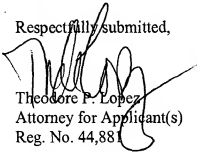
The undersigned hereby certifies in accordance with §1.97(e)(1) that each item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

Applicant(s) believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 50-2257. Please deduct any additional fees from, or credit any overpayment to the above-noted Deposit Account.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on November 26, 2002.

Sandy Kim
November 26, 2002
Date of Signature

Respectfully submitted,


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U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No.		Serial No.		
				M-8608 US		09/828,518		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant(s)				
(Use several sheets if necessary)				Woo Sik Yoo				
				Filing Date		Group		
				April 6, 2001		2812		
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA							
	AB							
	AC							
	AD							
	AE							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AF	EP0334664A	09/27/89	Europe			Yes	
	AG	JP58223612A	12/26/83	Japan			Yes	
	AH	JP63045199A	02/26/88	Japan			Yes	
	AI	EP0771887A	05/07/97	Europe			Yes	
	AJ							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AK							
	AL							
	AM							
Examiner			Date Considered					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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